

Docket No.: 50006-073



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Isao NOJIRI, et al.

Serial No.:

Group Art Unit:

Filed: September 05, 2000

Examiner:

For: SEMICONDUCTOR DEVICE AND ITS WIRING METHOD

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Serial No.:

Each non-English language reference is accompanied by an English abstract.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

A handwritten signature in black ink, appearing to read "Becker", written over a horizontal line.

Stephen A. Becker

Registration No. 26,527

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 SAB:klm
Date: September 5, 2000
Facsimile: (202) 756-8087

SERIAL NO.

FILING DATE
**September 05,
2000**

GROUP

(PTO-1449)

[illegible]

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
	57-103322	June 26, 1982	JAPAN (with English abstract)				

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.